

Technology-Independent Analysis of the Double Current-Gain Peak in Millimeter-Wave FETs

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Abstract—This letter is aimed at discovering and analyzing anomalous phenomena affecting millimeter-wave FETs, focusing on a GaN HEMT as a case study. For the first time, we show that the real parts of the impedance parameters can increase and then decrease with frequency, due to the resonance of the extrinsic reactive elements. This resonance may be detected as a peak in the magnitude of the short-circuit current-gain. Such a peak is found to be substantially bias and temperature insensitive and to manifest at frequencies higher than the other current-gain peak, due to the resonance between intrinsic capacitances and extrinsic inductances, giving origin to the double current-gain peak.

Index Terms—Current-gain peak, equivalent circuit, scattering parameters, semiconductor device modeling, temperature.

I. INTRODUCTION

Understanding anomalies affecting the millimeter-wave FET performance is essential in helping technologists to manufacture devices having the most nearly ideal characteristics, modelers to mimic the real device behavior, and designers to get the targeted circuit specifications. A few relevant examples of these anomalous phenomena are: the kink in the output reflection coefficient (S_{22}) [1]-[3], the dips in the magnitudes of the impedance (Z -) parameters turning into kinks in the magnitudes of the hybrid (h -) parameters [3]-[6], and the high-frequency increase of the real parts of the Z -parameters [7]-[9]. The kink in S_{22} has been mainly ascribed to the relatively high transconductance (g_m) [1]-[3]. The dips in the Z -parameter magnitudes have been ascribed to the resonance between intrinsic capacitances and extrinsic

inductances [3]-[5]. In particular, the dip in the magnitude of the open circuit output impedance (Z_{22}) can lead to a peak in the magnitude of the short-circuit current-gain (h_{21}), which has been referred to as the current-gain peak (CGP) [4]. The high-frequency increase of $\text{Re}(Z_{ij})$ has been called PDRZ effect, since it implies a positive derivative of $\text{Re}(Z_{ij})$ versus frequency, and its origin has been associated with the concurrence of extrinsic capacitive and inductive effects [7]-[9]. With the aim of exploring so far uninvestigated anomalies in the millimeter-wave FET performance, this study is focused on the behavior of a $0.25 \times 1500 \mu\text{m}^2$ GaN HEMT up to 65 GHz. The choice of investigating a large device at high frequencies is motivated by the fact that the intrinsic terminals tend to be quicker shorted by increasing the frequency and the gate width, thereby enhancing anomalies arising from the extrinsic reactive elements. We will show theoretically and experimentally that the resonance between the extrinsic capacitances and inductances can cause peaks in $\text{Re}(Z_{ij})$, due to the transition from PDRZ to NDRZ effect. By contrast to PDRZ, the acronym NDRZ is coined here to refer to the negative derivative of $\text{Re}(Z_{ij})$ versus frequency. The peaks in $\text{Re}(Z_{ij})$ can turn into peaks in the Z -parameter magnitudes. Among these peaks, the one occurring in the magnitude of the open-circuit forward transfer impedance (Z_{21}) can be responsible for a further peak in the magnitude of h_{21} at frequencies higher than the resonance frequency between intrinsic capacitances and extrinsic inductances. Generally, the resonance of the extrinsic reactive elements manifests at a higher frequency, due to the smaller values of the extrinsic capacitances compared to the intrinsic ones. These considerations allow explaining that h_{21} can be affected by the phenomenon called by us double current-gain peak (DCGP). The first CGP depends slightly on temperature and strongly on bias point [3]-[6], whereas the second CGP is almost insensitive to both conditions. It is worth noting that the developed theoretical analysis is technology independent. As a matter of fact, the DCGP is simply due to the circuit element values of the tested FET, besides to the working frequency. This is corroborated by previous studies focused on GaAs and GaN devices affected by the first CGP [3]-[9]. Furthermore, although the second CGP has not so far been observed experimentally, we were able to detect this effect by simulating

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the extracted models beyond the upper frequency limit of our experiments [3]-[5], [7]-[9].

II. THEORETICAL AND EXPERIMENTAL STUDY OF THE DCGP

Typically, the small-signal FET equivalent-circuit consists of eight extrinsic elements (i.e., C_{pg} , C_{pd} , L_g , L_s , L_d , R_g , R_s , and R_d) and eight intrinsic elements (i.e., C_{gs} , C_{gd} , C_{ds} , R_{gs} , R_{gd} , R_{ds} , g_m , and τ_m), as illustrated in Fig. 1. The intrinsic terminals can be assumed to be short-circuited for large devices at high frequencies, due to the reduction of the impedances associated with the intrinsic resistances and capacitances. This assumption enables defining $\text{Re}(Z_{11})$ and $\text{Re}(Z_{22})$ as follows [7]:

$$\text{Re}(Z_{11}) = \frac{R_g + R_s}{(1 - \omega^2 C_{pg} L_{sg})^2} \quad (1)$$

$$\text{Re}(Z_{22}) = \frac{R_d + R_s}{(1 - \omega^2 C_{pd} L_{sd})^2} \quad (2)$$

where L_{sg} and L_{sd} are given by $L_s + L_g$ and $L_s + L_d$, respectively.

Equations (1) and (2) indicate that the resonance frequencies associated to the peaks in $\text{Re}(Z_{11})$ and $\text{Re}(Z_{22})$ are:

$$f_{RZ11} = \frac{1}{2\pi\sqrt{C_{pg} L_{sg}}} \quad (3)$$

$$f_{RZ22} = \frac{1}{2\pi\sqrt{C_{pd} L_{sd}}} \quad (4)$$

Along the same lines, similar considerations can be made for $\text{Re}(Z_{12})$ and $\text{Re}(Z_{21})$ but, since each of these two parameters can be influenced by both C_{pg} and C_{pd} , the corresponding equations result to be much less intuitive. According to the aforementioned analysis, the resonance of the extrinsic reactive elements can lead to the transition from a positive to a negative derivative of $\text{Re}(Z_{ij})$ versus frequency, implying peaks in the real parts and magnitudes of the Z -parameters. It is worth highlighting that the frequency dependence of Z_{21} and Z_{22} can strongly impact on h_{21} (i.e., $h_{21dB} = Z_{21dB} - Z_{22dB}$). This observation allows explaining that the magnitude of h_{21} can be affected by the DCGP consisting of two peaks: the first one due to a dip in Z_{22} , originating from the resonance between intrinsic capacitances and extrinsic inductances [4], and the second one due to a peak in Z_{21} , originating from the resonance between extrinsic capacitances and inductances. The origin of the first CGP has been already demonstrated to be caused by the resonance between L_{sd} and C_T , given by C_{ds} in parallel with the series capacitance of C_{gs} and C_{gd} [4].

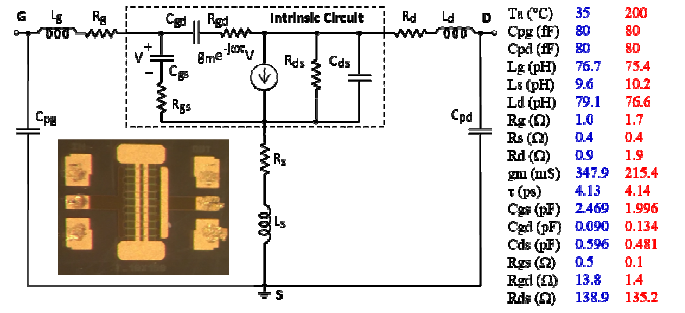


Fig. 1. Standard FET equivalent circuit and element values for the illustrated GaN HEMT at $V_{GS} = -3.1$ V and $V_{DS} = 30$ V with $T_a = 35^\circ\text{C}$ and $T_a = 200^\circ\text{C}$.

The present study is based on S -parameters measured from 0.2 to 65 GHz on a $0.25 \times 1500 \mu\text{m}^2$ GaN HEMT on SiC at four ambient temperatures (T_a): 35°C , 90°C , 145°C , and 200°C . An LRM off-wafer calibration is performed using a GGB Industries CS-5 substrate. The extrinsic elements are extracted from S -parameters at “cold” pinch-off condition, thereby enabling the determination of the intrinsic elements from the intrinsic admittance (Y -) parameters. The effects of C_{pg} and C_{pd} are de-embedded from the measurements by using a circuit simulator and their values are determined by gradually increasing them from zero until the PDRZ and NDRZ effects disappear from the de-embedded data. The PDRZ and NDRZ effects are found to vanish for all the analyzed T_a by de-embedding the same extrinsic capacitance values. This is illustrated in Fig. 2 showing the results under “cold” pinch-off condition at the lowest and highest T_a . The achieved result agrees with the fact that the PDRZ and NDRZ effects originate from the counterbalance between extrinsic inductive and capacitive effects and that the extrinsic capacitances are mostly insensitive to T_a [9], [10]. The validity of our theoretical analysis is also confirmed by the fact that the transitions from PDRZ to NDRZ effect in Z_{11} and Z_{22} occur at frequencies around 60 GHz as predicted by (3) and (4) (i.e., $f_{RZ11} = 60.6$ GHz and $f_{RZ22} = 59.7$ GHz at 35°C). The extracted model is able to mimic the measured S -parameters and thus to capture the behavior of h_{21} at $V_{GS} = -3.1$ V and $V_{DS} = 30$ V (see Fig. 3). As predicted, the resonance of the extrinsic reactive elements leads to a peak in h_{21} at around 60 GHz. In particular, the experimental results show peaks in the real parts and magnitudes of all the four Z -parameters but the peak in Z_{21} is much more pronounced than the peak in Z_{22} , thereby turning into a peak in h_{21} at around 60 GHz (see Fig. 4). Furthermore, a dip in Z_{22} leads to the appearance of the first peak in h_{21} . The estimated value of the resonance frequency associated to L_{sd} and C_T is 20.4 GHz, consistently with the measurements and simulations showing the first CGP at 15.4 GHz and 20.6 GHz, respectively. Fig. 4(d) shows that the second CGP occurs at a frequency greater than the unity current-gain cut-off frequency (f_T) and the maximum oscillation frequency (f_{MAX}) (i.e., $f_T = 21.2$ GHz and $f_{MAX} = 36$ GHz). Fig. 5 shows the temperature dependence of the magnitude of h_{21} at four bias conditions. For the sake of completeness, the device is also biased by imposing I_{DS} rather than V_{GS} , in order to compensate for

variations in I_{DS} with T_a . As can be observed, the second CGP is roughly independent of T_a for all the studied bias points, consistently with the fact that the extrinsic capacitances and inductances are mostly insensitive to T_a [9], [10]. It is obtained that also the first CGP is roughly independent of T_a , coherently with the fact that the intrinsic capacitances depend only slightly on T_a . The first CGP disappears at zero V_{DS} , owing to the reduction of R_{ds} that tends to short circuit the intrinsic capacitive effects on Z_{22} [4]. On the other hand, the second CGP is not affected by the reduction of R_{ds} , as the resonance of the extrinsic reactive elements occurs at such high frequencies that the intrinsic terminals can be already assumed shorted.

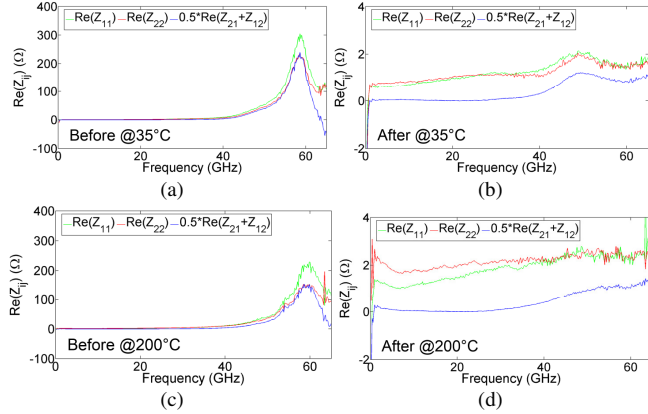


Fig. 2. Measured $\text{Re}(Z_{ij})$ for a GaN HEMT at $V_{GS} = -4$ V and $V_{DS} = 0$ V with (a, b) $T_a = 35^\circ\text{C}$ and (c, d) $T_a = 200^\circ\text{C}$: (a, c) before and (b, d) after de-embedding the extrinsic capacitances.

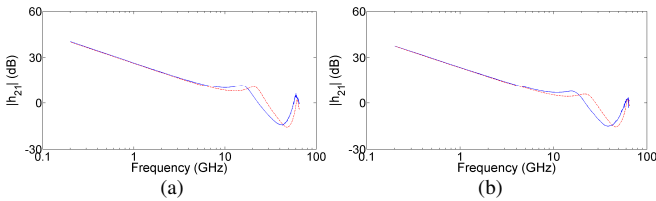


Fig. 3. Measured (blue lines) and simulated (red lines) $|h_{21}|$ for a GaN HEMT at $V_{GS} = -3.1$ V and $V_{DS} = 30$ V with (a) $T_a = 35^\circ\text{C}$ and (b) $T_a = 200^\circ\text{C}$.

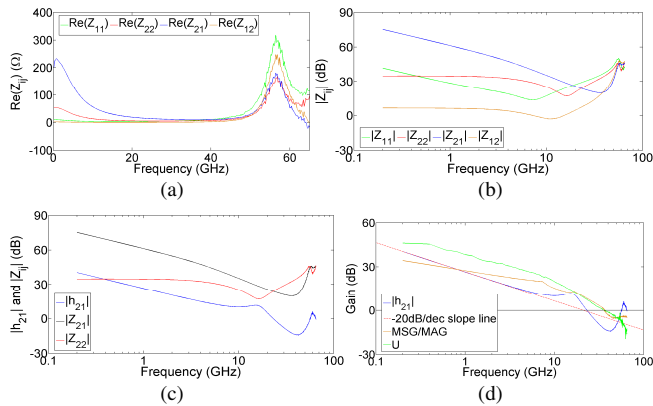


Fig. 4. Measured (a) $\text{Re}(Z_{ij})$, (b) $|Z_{ij}|$, (c) $|h_{21}|$, $|Z_{21}|$, and $|Z_{22}|$, (d) $|h_{21}|$, MSG/MAG, and U for a GaN HEMT at $V_{GS} = -3.1$ V and $V_{DS} = 30$ V.

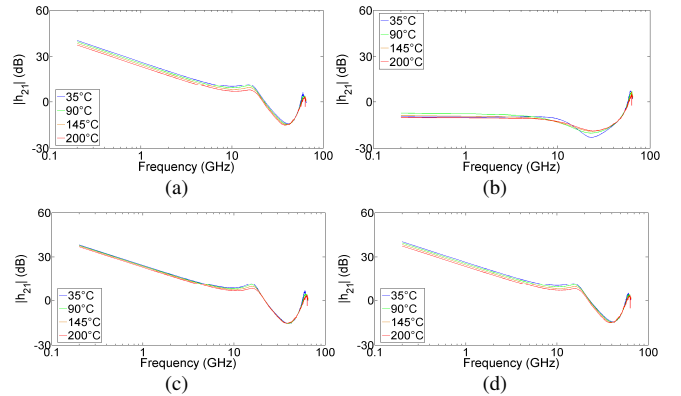


Fig. 5. Measured $|h_{21}|$ for a GaN HEMT at four T_a and at four bias points: (a) $V_{GS} = -3.1$ V and $V_{DS} = 30$ V; (b) $V_{GS} = -3.1$ V and $V_{DS} = 0$ V; (c) $V_{GS} = -3.5$ V and $V_{DS} = 30$ V; (d) $I_{DS} = 170$ mA and $V_{DS} = 30$ V.

III. CONCLUSIONS

This letter has shown that the studied double current-gain peak phenomenon is inherent in any FET and its onset results in two sudden increases of current gain at two resonance frequencies, thereby making this effect very attractive. An accurate analysis of the double current-gain peak represents a powerful tool for microwave engineers. For fabrication purpose, electromagnetic simulations of the device layout can properly describe the parasitic reactive network, by which it is possible to predict and control the resonance frequencies before fabricating the device. This enables an optimization of the device layout prior to fabrication, depending on the application constrains. For modeling purpose, the extrinsic capacitances can be determined by exploiting the fact that the PDRZ and NDRZ effects vanish by subtracting appropriate values of extrinsic capacitances. This is an elegant way to overcome the well-known limitation of the conventional “cold” approach that does not allow distinguishing between the extrinsic and intrinsic output capacitances, without the need of using optimization algorithms or additional test structures. For design purpose, the second current-gain peak can enable a current gain greater than unity even at frequencies beyond f_T and f_{MAX} . This finding extends and complements previous studies in which attention on achieving current-gain peaks even at frequencies beyond f_T has been restricted to bipolar transistors, mostly based on proper design of the so-called resonance phase transistor.

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